

# Asynchronous Charge Carrier Injection in Perovskite Light-Emitting Transistors

Maciej Klein, Krzysztof Blecharz, Bryan Wei Hao Cheng, Annalisa Bruno, and Cesare Soci\*

Unbalanced mobility and injection of charge carriers in metal-halide perovskite light-emitting devices pose severe limitations to the efficiency and response time of the electroluminescence. Modulation of gate bias in methylammonium lead iodide light-emitting transistors has proven effective in increasing the brightness of light emission up to MHz frequencies. In this work, a new approach is developed to improve charge carrier injection and enhance electroluminescence of perovskite light-emitting transistors by independent control of drain–source and gate–source bias voltages to compensate for space-charge effects. Optimization of bias pulse synchronization induces a fourfold enhancement of the emission intensity. Interestingly, the optimal phase delay between biasing pulses depends on modulation frequency due to the capacitive nature of the devices, which is well captured by numerical simulations of an equivalent electrical circuit. These results provide new insights into the electroluminescence dynamics of AC-driven perovskite light-emitting transistors and demonstrate an effective strategy to optimize device performance through independent control of the amplitude, frequency, and phase of the biasing pulses.

emitting transistors (PeLETs) integrate two key functionalities of electrical switching and light emission, providing a powerful testbed to study charge transport and recombination processes in semiconducting materials.<sup>[5,6]</sup> The most recent applications of PeLETs include studies of light-matter interaction in nanophotonic cavities under electrical injection<sup>[7]</sup> and electrically tunable polarized light sources.<sup>[7,8]</sup> Like most hybrid perovskite devices, PeLETs suffer from environmental instability related to intrinsic material limitations, such as temperature-activated trapping, ionic motion, and polarization effects, which reduce their device performance, namely brightness, modulation rate, and uniformity of the recombination zone. Pulsed operation (i.e., AC modulation of the gate bias) has proven to be a viable route to overcome some of these limitations by minimizing

ionic vacancy drift and organic cation polarization and improving space-charge field-assisted injection.<sup>[9,10]</sup> An in-depth understanding of the electroluminescence (EL) response under rectangle voltage bias pulses is essential for practical applications of these devices, for example, active matrix displays and optical wireless communication.<sup>[11,12]</sup>

## 1. Introduction


In recent years, metal-halide perovskites have shown great potential for optoelectronic devices such as solar cells, photodetectors, X-ray scintillation detectors, and light-emitting diodes (LEDs).<sup>[1–3]</sup> Besides conventional transistors,<sup>[4]</sup> perovskite light-

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Previous studies on AC-operated perovskite light-emitting diodes have focused on the minimization of ionic motion,<sup>[13–15]</sup> enhancement of brightness and operation stability,<sup>[16,17]</sup> operating current density reduction,<sup>[18]</sup> dynamic electroluminescence response,<sup>[13,15,19]</sup> and direct integration of LEDs into AC power system.<sup>[20]</sup> This suggests that similar improvements could be achieved in PeLETs through the independent control of source, drain, and gate pulse bias parameters.

In this work, we investigate the performance of PeLETs operating in two different pulsed operation modes. Due to the difference in carrier mobilities, injection energy barriers, and gate potential screening by mobile charged ions, a number of parameters affect the actual electron and hole charge carrier densities within the recombination zone of the transistor channel. We show that more than fourfold enhancement of electroluminescence intensity can be achieved by controlling the amplitude and electrical polarization of the bias pulses applied to drain and gate terminals and their relative phase, duty cycle, and modulation frequency. This is attributed to the compensation of space-charge effects by alternating currents and to the better overlap of electron and hole distributions within the recombination zone upon asynchronous injection from the electrodes. We develop a comprehensive equivalent circuit model that accounts for both DC and AC responses of the PeLET and use LTspice numerical simulation software to assess the impact of capacitive effects on radiative recombination and the overall electroluminescence intensity of the device.

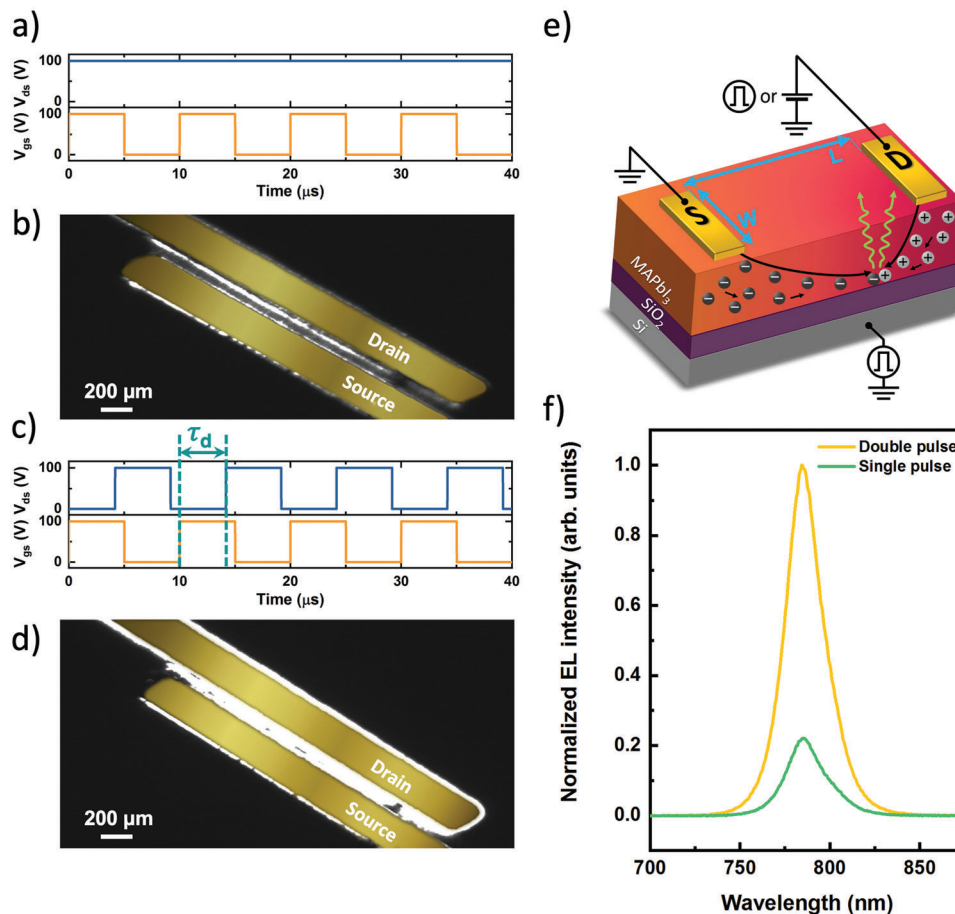
## 2. Results and Discussion

The light-emitting transistors based on co-evaporated methylammonium lead iodide (CH<sub>3</sub>NH<sub>3</sub>PbI<sub>3</sub>) MAPbI<sub>3</sub> perovskite used in this study have similar architecture and electrical characteristics as those described in previous works.<sup>[10,21]</sup> They show ambipolar charge carrier injection with low-temperature transport dominated by electrons with an on-off ratio of  $\approx 10^4$ . When operated in the *n*-type regime at  $V_{ds} = 60$  V, the field-effect electron mobility  $\mu_e = (8.6 \pm 0.6) \times 10^{-2} \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$  is almost three orders of magnitude higher than the hole mobility  $\mu_h = (1.3 \pm 0.3) \times 10^{-4} \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$ . To understand and improve their light emission properties, we investigated the transistor operation in two biasing conditions (**Figure 1**): i) Single pulse mode (**Figure 1a,e**), where a constant voltage bias is applied to the drain–source (D–S) electrodes, and a pulsed voltage (square wave) is applied to the gate–source (G–S) electrodes; ii) Double pulse mode (**Figure 1c,e**), where a pulsed voltage bias is applied to both drain and gate terminals. In single pulse mode, gate pulses induce the formation of the inversion layer and the synchronous injection of charge carriers from the source and drain electrodes. As a result of unbalanced carrier mobilities, the space-charge effect, and capacitive delay, holes and electrons are not uniformly distributed within the channel. Hence, the position of the recombination zone is offset from the center of the channel, and the electroluminescence intensity, spatially constrained within a narrow emission line, is weak (**Figure 1b**; magnified view in **Figure S1a**, Supporting Information). In double pulse mode, gate and drain pulses are controlled independently. By introducing a phase delay between the pulses,  $\Delta\varphi = \frac{\tau_d}{T} \times 360$ , where  $\tau_d$  is the delay between pulses and  $T$  is the modulation period (**Figure 1c**), asynchronous

injection of charge carriers can be used to achieve spatial and temporal overlap of electron and hole distributions within the recombination zone. The lateral electric field between source and drain electrodes induces charge carriers to drift and recombine throughout the channel, resulting in a widely spread emission zone (**Figure 1d**; magnified view in **Figure S1b**, Supporting Information). At the optimal phase delay of  $\Delta\varphi = 150$  deg between biasing pulses, and modulation frequency of 100 kHz, the integrated EL intensity in double pulse mode is 4.5 times higher than in single pulse mode (**Figure 1f**).

The electroluminescence observed in the AC-driven PeLETs appears to originate from two separate mechanisms. EL emitted from within the transistor channel is attributed to band-to-band radiative recombination of electrons and holes injected from the top S and D electrodes, while EL emitted from beneath and in close proximity of the drain and source electrodes is associated with AC field-induced space-charge recombination.<sup>[9,22]</sup> Interestingly, these two effects can be spatially resolved in the optical images of the PeLET operated in the double pulse mode with different phase delays (and the difference becomes more apparent at high modulation frequency, e.g., 500 kHz), **Figure 2**. At a phase delay of  $\Delta\varphi = 0$  deg (**Figure 2a**), AC field-induced recombination around the top electrodes is dominant, while at  $\Delta\varphi = 30$  deg (**Figure 2b**) light is emitted uniformly throughout the channel, suggesting that both recombination processes may be equally involved. Further increase of the phase delay leads to strong EL emission from the center of the channel, governed by band-to-band recombination of the injected charge carriers (**Figure 2c**), which saturates at  $\Delta\varphi = 120$  deg (**Figure 2d**). A continuous-frame video showing the tunability of the EL intensity and the position of the emission zone as a function of  $\Delta\varphi$  is provided as **Movie S1** (Supporting Information).

In addition to the relative phase of the drain and gate pulses, double pulse mode operation provides additional degrees of freedom to control the EL intensity of PeLETs, that is, duty cycle ( $\delta = \frac{\tau_{on}}{T} \times 100\%$ , where  $\tau_{on}$  is pulse width) and modulation frequency ( $f$ ) of the individual drain and gate pulses (**Figure 3**). The dependence of the integrated EL intensity on the phase between the drain and gate pulses ( $\Delta\varphi$ ), at a constant duty cycle of  $\delta = 50\%$  and modulation frequency of 100 kHz (pulse width of  $\tau_{on} = 5 \mu\text{s}$ ), is shown in **Figure 3a** (a diagram of the corresponding biasing pulse trains is shown in **Figure S2**, Supporting Information). Surprisingly, the EL intensity emitted by the PeLET does not reflect the temporal overlap between the drain and gate pulses as a function of their dephasing. In fact, the maximum emission intensity occurs when the gate and drain pulses are out of phase and their temporal overlap is minimal ( $\Delta\varphi = 150\text{--}180$  deg). Drain and gate duty cycles have a similar effect on the EL intensity, with maxima occurring at  $\delta = 50\%$  (**Figure 3b,c**). Thus, neither prolonging the formation of the inversion layer by increasing the gate duty cycle nor prolonging charge carrier injection by increasing the drain duty cycle increases the emission intensity as one might expect. As the drain duty cycle controls charge carrier injection (i.e., with longer drain–source pulses, more carriers are injected into the channel), while the gate duty cycle modulates transport within the channel (i.e., longer pulses extend the on state of the transistor), this indicates that the charge carrier recombination dynamics responsible for light emission occur on a time scale comparable to that of the biasing pulses (faster recombination dynamics

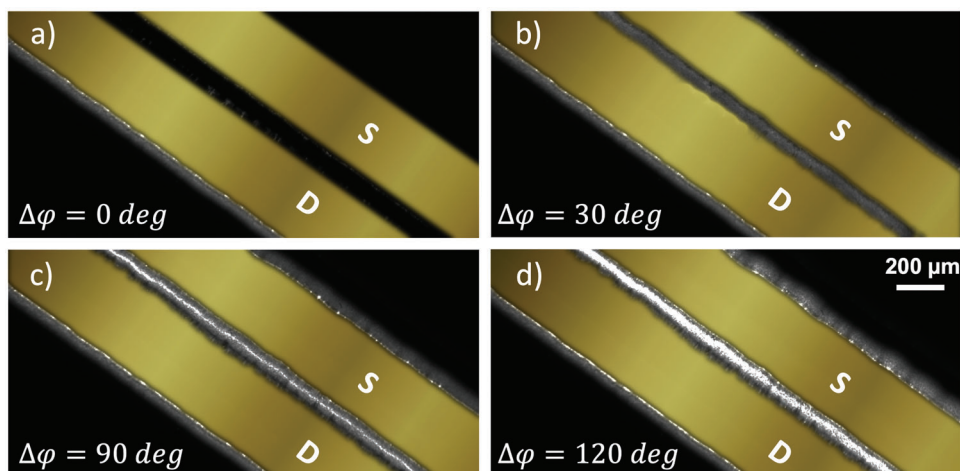


**Figure 1.** PeLET emission under single and double pulse mode. a, c) Waveform charts of biasing voltages ( $V_{ds}$  and  $V_{gs}$ ) and b, d) corresponding optical images of the EL emission of PeLET devices under single pulse mode (biasing conditions:  $V_{ds} = 100$  V,  $V_{gs} = 0 \div 100$  V) and double pulse mode (biasing conditions:  $V_{ds} = 0 \div 100$  V,  $V_{gs} = 0 \div 100$  V), respectively. The delay time,  $\tau_d$ , between gate and drain pulses is marked in panel c). e) Schematic of the PeLET device architecture and biasing configuration for i. single pulse mode: DC-biased drain electrode and pulsed-biased gate electrode; ii. double pulse mode: pulsed-biased drain and gate electrodes. Channel length  $L = 100$   $\mu\text{m}$  and width  $W = 1$  mm are marked with blue arrows. f) Comparison of EL spectra under both modes. For double pulse mode phase delay is 150 deg. Measurements were performed at 77 K and 100 kHz modulation frequency. Source and drain electrodes in panels b and d were false colored for better contrast.

would eliminate the dependence on duty cycle, while slower recombination dynamics would lead to an optimal duty cycle skewed toward the highest amplitude or the longest decay pulse, with maximum EL brightness at an asymmetric duty cycle). The dependencies of simulated transient drain–source current waveforms (proportional to emission intensity) of the PeLETs for different duty cycles of the biasing pulse are shown in Figure S3 (Supporting Information). Note that the second maximum observed at  $\delta = 70\%$  (Figure 3b) occurs when the drain pulse overlaps with the gate pulse of the following cycle (Figure S4a, Supporting Information). Furthermore, the gate duty cycle yielding maximum EL intensity (Figure 3c) corresponds to minimal overlap between gate and drain pulses (Figure S4b, Supporting Information). At a larger modulation frequency of 500 kHz ( $\tau_{on} = 1$   $\mu\text{s}$ ), the highest EL intensity is obtained at a smaller phase delay of 120 deg, Figure S5a (Supporting Information) (corresponding to a pulse delay of 0.67  $\mu\text{s}$ , Figure S2b, Supporting Information), while the optimal gate and drain duty cycles remain 50%

(Figures S5b,c and S6, Supporting Information), consistent with the results at 100 kHz.

The optimal phase delay between pulses may be related to the formation time of the inversion layer within the perovskite film, with its peculiar dependence on modulation frequency reflecting the inherent capacitive effects of the perovskite. A simple model to describe the operation of FETs consists of two separate metal-insulator-semiconductor (MIS) diodes representing the gate/source and the gate/drain electrode pairs, with the intrinsic capacitance of the diodes defining the dynamic response of the transistor. To apply this model to our devices, the capacitance  $C(f)$  of an equivalent MIS structure, Si/SiO<sub>2</sub> (500 nm)/MAPbI<sub>3</sub> (400 nm)/Au (100 nm), was measured by impedance spectroscopy as a function of modulation frequency (Figure S7, Supporting Information). In such a MIS structure, the total capacitance  $C$  is given by the combination of the insulator capacitance  $C_i$  (SiO<sub>2</sub>) and the semiconductor layer capacitance  $C_s$  (MAPbI<sub>3</sub>) connected in series:  $C = \frac{C_i C_s}{C_i + C_s}$  [23] A significant



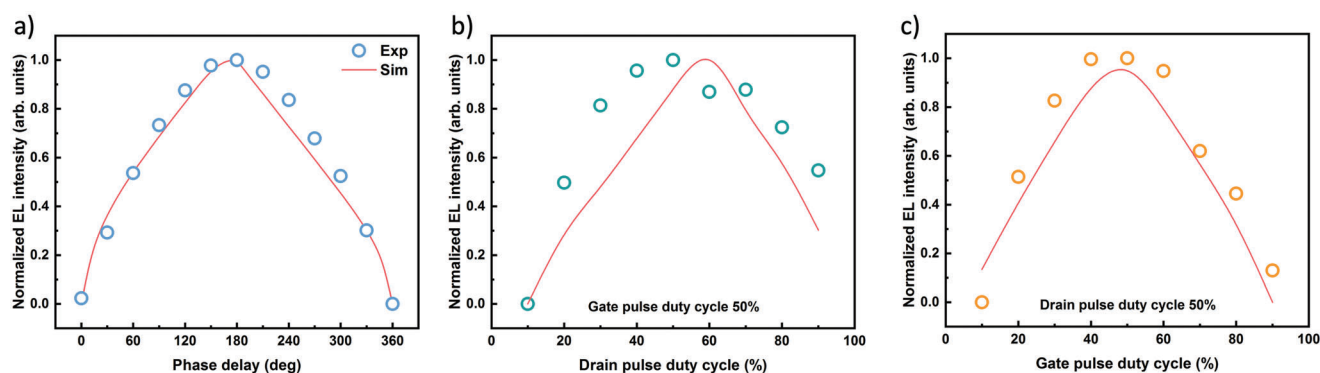
**Figure 2.** Electroluminescence of PeLET under asynchronous injection. a–d) Optical images of the EL emission of PeLET devices at various phase delays between drain and gate pulses. Dephasing the source relative to the gate pulses from a)  $\Delta\varphi = 0$  deg to d)  $\Delta\varphi = 120$  deg modifies the recombination zone within the channel and progressively increases the brightness of EL. Measurements were performed at 77 K and 500 kHz modulation frequency. Source and drain electrodes were false colored for better contrast.

decrease in capacitance at frequencies  $>7 \times 10^4$  Hz is clearly visible in the data. Such frequency dependence of  $C(f)$  is consistent with prior literature reports for spin-coated perovskite films, that attributed the reduction of  $C_s$  at high frequencies to polarization effects.<sup>[24,25]</sup> The overall capacitance is related to the time constant of the equivalent RC circuit,  $\tau = RC$ , where  $R$  is the equivalent circuit resistance. Hence, a decrease of  $C(f)$  at a high modulation frequency shortens  $\tau$ .

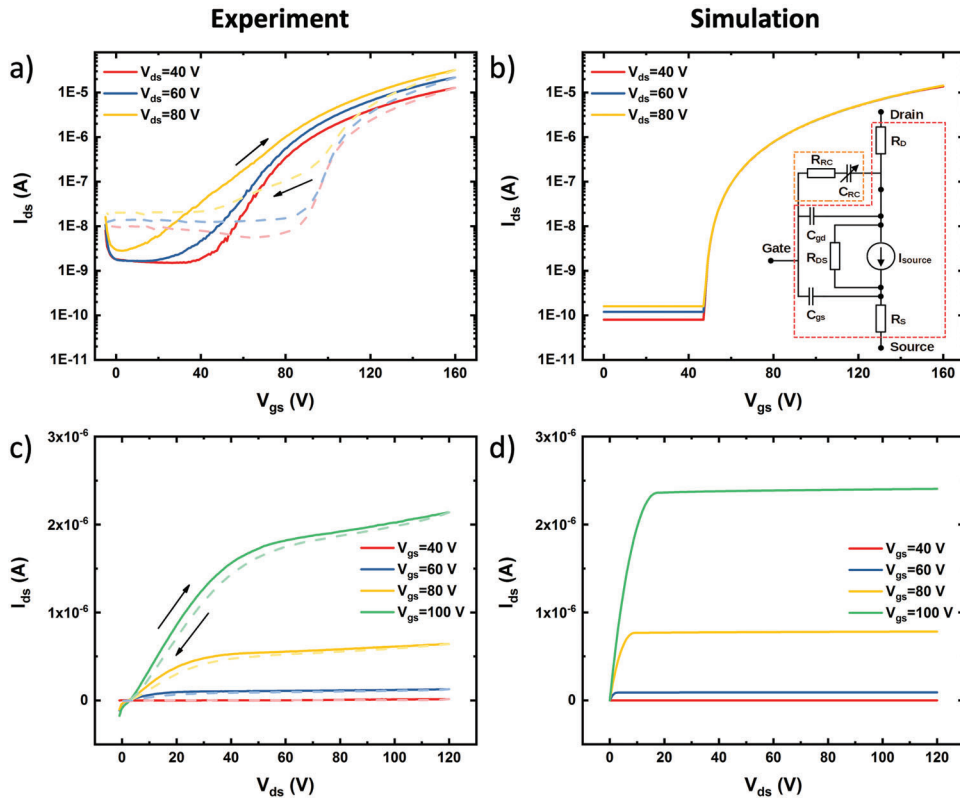
DC electrical characteristics of the PeLETs are shown in **Figure 4**. The electrical model was implemented in LTSpice software using the mathematical Grove–Frohmman model for metal-oxide-semiconductor field-effect transistor (MOSFET) and the experimentally determined capacitances, as shown in the red dashed box in the inset of **Figure 4b**.<sup>[26]</sup> The measured  $n$ -type transfer and output characteristics of PeLETs shown in **Figure 4a,c** are in good agreement with the simulated curves (**Figure 4b,d**). The gain of  $I_{ds}$  with increasing  $V_{gs}$  voltage in transconductance curves, as well as  $I_{ds}$  saturation currents, are comparable. The main discrepancy between sim-

ulations and experiments is the lack of electrical hysteresis arising from slow ionic motion and organic cation polarization disorder. These effects are not included in the model since they are effectively reduced upon AC-modulation at frequencies  $>10^4$  Hz.<sup>[9,10,27,28]</sup>

The complex dependence of the EL intensity signal on the phase delay observed in **Figure 3** cannot be solely explained by the simple model of a metal-oxide-semiconductor field-effect transistor (MOSFET). To unveil the nature of the transport dynamics in the PeLET, we performed transient electroluminescence measurements under double pulse mode operation and implemented a modified version of the MOSFET equivalent circuit (**Figure 5**). To account for the multi-peak character of the measured EL, in which emission peaks are unexpectedly observed at the decaying edge of the gate pulses, the new electrical circuit model includes an additional RC branch (comprising  $R_{RC}$  and  $C_{RC}$ ) driven by the gate voltage, as shown in the orange dashed box in the inset of **Figure 4b**. The generalized rate equation describing the populations of electrically injected free charge



**Figure 3.** Electroluminescence dynamics versus the pulse duty cycle. a) Phase delay dependent EL intensity and EL intensity dynamics versus b) drain pulse duty cycle (constant gate pulse  $\delta = 50\%$ ) and c) gate pulse duty cycle (constant drain pulse  $\delta = 50\%$ ). Measurement conditions: 100 kHz modulation frequency, 150 deg phase delay (for panels b and c).



**Figure 4.** DC electrical characteristics of the PeLETs. a,c) Measured and b,d) simulated *n*-type a,b) transfer and c,d) output characteristics under the constant drain ( $V_{ds}$ ) and gate ( $V_{gs}$ ) bias indicated in the panels, at 77 K. Solid lines were obtained in the forward direction while dashed lines in the reverse direction of the voltage sweep. The inset of panel (b) shows equivalent circuit of the developed PeLET model.

carriers under steady-state conditions can be written as:

$$\frac{j_i^e}{qL} - \left( \frac{1}{\tau_T^e} + \frac{1}{\tau_{rec}^e} \right) n_e = 0 \quad (1)$$

$$\frac{j_i^h}{qL} - \left( \frac{1}{\tau_T^h} + \frac{1}{\tau_{rec}^h} \right) n_h = 0 \quad (2)$$

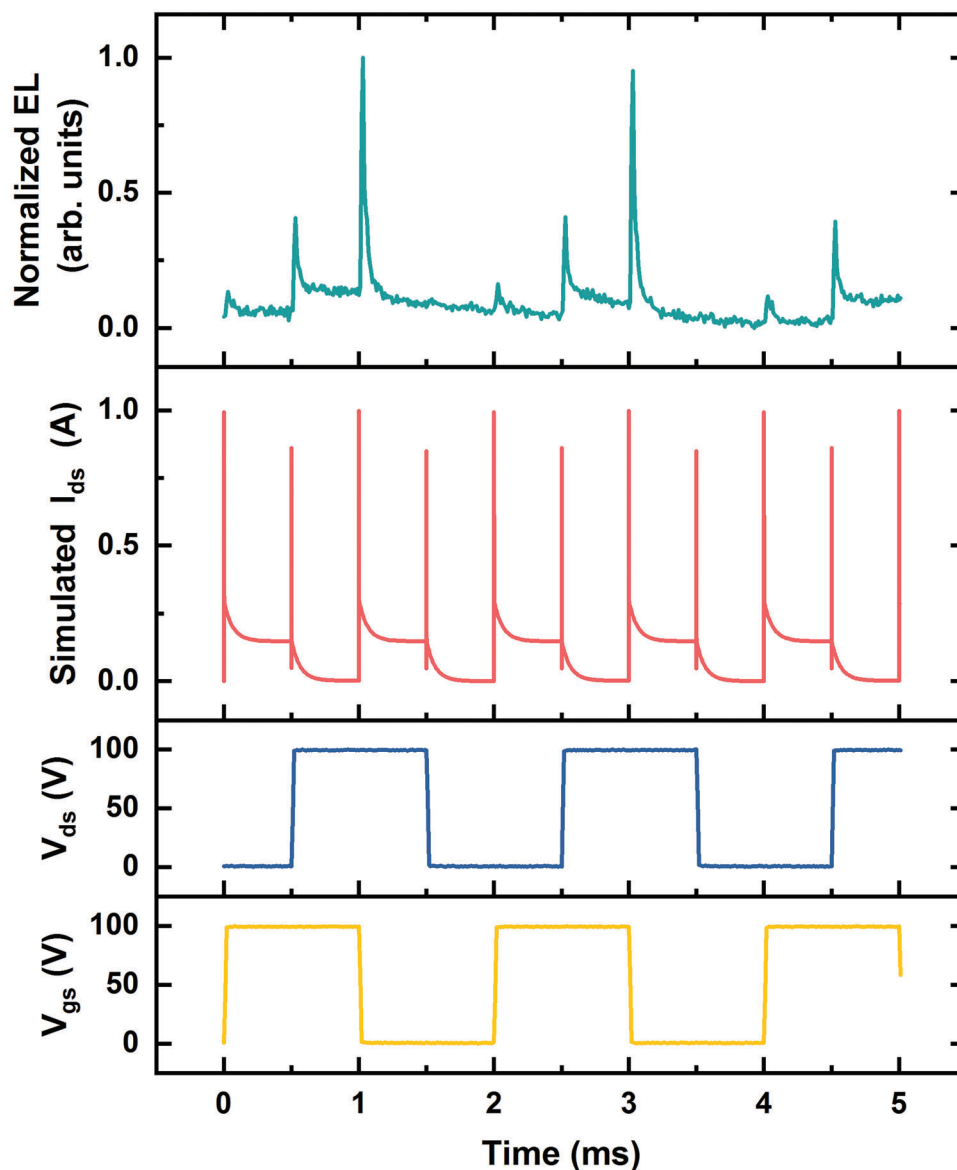
where  $j_i^e$  and  $j_i^h$  are electron and hole injection currents,  $q$  is the elementary charge,  $L$  is the transistor channel length,  $\tau_T = \frac{L}{\mu F}$  is the carrier transit time dependent on the carrier mobility,  $\mu$  and electric field  $F$ , operating in the sample,  $\tau_{rec} = \frac{1}{\gamma n}$  is the recombination time of charge carriers,  $n_e$  and  $n_h$  are carrier concentrations, and  $\gamma$  is the recombination coefficient for the injected carriers.<sup>[29,30]</sup> In a planar architecture of light emitting transistors, positive and negative space charges overlap throughout the channel length with the charge carrier transit time ( $\sim 10^{-3}$  s) much greater than their recombination time,  $\tau_T > \tau_{rec}$ , leading to a volume-controlled electroluminescence with decay dominated by the second-order process of carrier recombination. In the volume-controlled EL regime, electron and hole carrier concentrations can be expressed as  $n_e \cong j_i^e / q\gamma n_h L$  and  $n_h \cong j_i^h / q\gamma n_e L$ , which imposes  $j_i^e = j_i^h = j$ . Thus, the photon flux per unit area

emitted from the PeLET can be written as:

$$\Phi_{EL} = \frac{k_r}{k_t} \frac{j}{q} \quad (3)$$

where  $k_r$  is a radiative decay rate constant,  $k_t = k_r + k_{nr}$  total decay rate constant,  $k_{nr}$  non-radiative decays rate constant, and  $j$  is an injection current.<sup>[30]</sup> Therefore, the  $\Phi_{EL}$  is a linear function of the drain–source current flowing through the sample, independent of the extension of the space charge overlap. Experimentally, this is confirmed by the direct proportionality of the EL to the drain–source current for a given gate voltage (see for instance Ref. [31]). Thus, the time dependence of the PeLET electroluminescence upon current injection in double pulse mode was directly compared to the simulated drain–source current waveforms (Figure 5).

The recorded EL signal shows sharp light emission peaks of lower intensity at the beginning of D–S pulses and high-intensity peaks at the end of G–S pulses (Figure 5). This may be attributed to the capacitive charging and discharging of the device, wherein the charge carriers are accumulated in the perovskite film, at the interface with the injecting electrodes, as previously observed for the EL dynamics of perovskite solar cells.<sup>[13]</sup> This suggests that under asynchronous pulsed conditions, source/drain and gate electrodes are capacitively coupled and the PeLET acts like a field-induced capacitive light-emitting device.<sup>[32]</sup> The EL decay is multiexponential, with three characteristic decay times,



**Figure 5.** Transient electroluminescence of the PeLETs. Time dependence of measured electroluminescence and simulated drain–source current. Schematic diagrams of the biasing pulse trains are shown in the bottom panels. Simulated  $I_{ds}$  is an absolute value and normalized. Measurement conditions: 500 Hz modulation frequency, 90 deg phase delay.

$\tau_1 = 7.1 \times 10^{-7}$  s,  $\tau_2 = 2.7 \times 10^{-5}$  s, and  $\tau_3 = 2.4 \times 10^{-4}$  s. The two fastest components may be attributed to the radiative decay responsible for light emission (the  $\tau_1$  time is not fully resolved due to the limitations of our experimental setup), while the sub-millisecond component could be ascribed to the slower screening effects of ionic motion and polarization.<sup>[9,27]</sup> Similarly, the simulated drain–source current (proportional to emission intensity) shows emission peaks and multiexponential decay dynamics that are in fairly good agreement with the experiments (Figure 5). Here, the fast component of the simulated decay,  $\tau_1 = 2.4 \times 10^{-7}$  s, is defined by the MOSFET part of the model with the  $C_{gs}$ , and  $C_{gd}$  capacitances set to the experimental values, while the two slower components are induced by the RC series circuit with  $R_{RC}C_{RC}$  time constants  $\tau_2 = 3.0 \times 10^{-5}$  and  $\tau_3 = 1.0 \times 10^{-4}$  s.

While  $\tau_2$  arises from the linear component of  $C_{RC}$ ,  $\tau_3$  stems from the nonlinearity of  $C_{RC}$  introduced by an additional parallel resistance and a parallel capacitance. This nonlinear capacitive term is necessary to reproduce the slow-decaying component of the EL and may be associated with energy dissipation in the circuit.

Further validation of the electrical circuit model with the determined time constants is provided by the dependence of the carrier density on the dephasing and duty cycle of the biasing pulses at a given modulation frequency (red lines in Figures 3 and S5, Supporting Information). The good agreement between the integrated carrier density and measured EL intensity over the entire range of biasing conditions, with no adjustable parameters, confirms the reliability of the model to describe the complex transport characteristics of PeLETs. Such model provides valuable in-

sights on the interplay between processes occurring at broadly different time scales, namely intrinsic radiative recombination of the perovskite excited states in the sub-microsecond regime, extrinsic capacitive effects related to device architecture at the microsecond time scale, as well as energy dissipation induced by ionic screening and polarization effects that persist up to milliseconds. Employing more stable perovskite compositions with suppressed ionic motion and higher luminescence quantum yields, as well as optimizing the PeLET geometry (i.e., channel dimensions and contacts shape) and improving its structure (via asymmetric contacts or adopting gate dielectric materials with different capacitance) may impact the phase-dependent emission profile and further improve electroluminescence brightness.<sup>[6,33]</sup>

### 3. Conclusion

In summary, we demonstrated that asynchronous charge injection yields a significant increase in the electroluminescence intensity of AC-driven perovskite light-emitting transistors. This is attributed to the compensation of ionic and polarization effects and the efficient utilization of injected charge carriers and accumulated space-charges upon the formation of an inversion layer. At a given modulation frequency, the optimal phase delay between the gate and drain–source pulses is determined by the capacitive properties of the perovskite layer. Based on the time-resolved and phase delay dependent electroluminescence characteristics of the PeLETs operated in the double pulse mode, we developed a comprehensive equivalent circuit model that accounts for both DC and AC responses, and unveils the impact of capacitive effects on radiative recombination and overall electroluminescence intensity. The reliability of the model was validated by numerical simulations of the PeLET electrical characteristics and of the drain–source current dependence on dephasing and duty cycle of the biasing pulses. The understanding of the relevant processes and their characteristic response time in PeLET devices provides new ways to optimize their architecture and output characteristics, potentially yielding orders of magnitude improvements in electroluminescence brightness and efficiency with optimized device structure and asynchronous biasing conditions. We foresee that the availability of bright and fast switchable PeLETs operating at room temperature, in conjunction with advanced metaoptics concepts recently demonstrated on this platform,<sup>[7,34]</sup> will substantially advance their application in lighting, active matrix displays, and optical wireless communication.<sup>[12,35,36]</sup>

### 4. Experimental Section

**Device Fabrication and Electrical Characterization:** PeLETs were fabricated in a bottom-gate and top-contact configuration on heavily *p*-doped Si substrates with a 500 nm thermally grown SiO<sub>2</sub> (capacitance of 6.9 nFcm<sup>-2</sup>) layer, following the processes described in previous work.<sup>[10]</sup> Methylammonium lead iodide, CH<sub>3</sub>NH<sub>3</sub>PbI<sub>3</sub> (MAPbI<sub>3</sub>), films were deposited by thermal co-evaporation of PbI<sub>2</sub> powder (TCI) and methylammonium iodide (MAI) powder (Lumtec) from effusion sources in high vacuum (pressure < 1 × 10<sup>-5</sup> mbar) using the conditions described in Ref. [21]. The top contact gold source and drain electrodes (channel length: 100 μm, channel width: 1 mm) were deposited by thermal evaporation through a shadow mask. Electrical measurements of the transistors were

carried out at 77 K in the dark and under the vacuum (10<sup>-3</sup> mbar) using a temperature-controlled electrical probing stage (Linkam HFS600E-PB4/PB2). The electrical characteristics were acquired with a 2-channel precision source/measure unit (Agilent B2902A). Charge-carrier mobilities were extracted from the forward sweeping of transfer characteristics obtained at V<sub>ds</sub> = ±60 V, using the conventional equation for metal-oxide semiconductor (MOS) transistors in the saturation regime: μ<sub>sat</sub> =  $\frac{2L}{WC_i} \left( \frac{\partial \sqrt{I_{ds}}}{\partial V_{gs}} \right)^2$ .

**Electroluminescence Measurements:** Pulsed electroluminescence measurements were performed by applying a square wave bias to the PeLET gate and drain electrodes, using a 2-channel arbitrary waveform generator (Rigol DG832) that allows for precise signal phase adjustment. The two output waveforms were subsequently amplified by separate high-voltage amplifiers (Falco Systems WMA-300), with a rise time and fall time <50 ns. Optical images were acquired by a sCMOS cooled monochrome scientific camera (PCO Edge 3.1 m) coupled to an optical microscope (Motic PSM-1000). The electroluminescence spectra were collected using a fiber-coupled spectrometer (Avantes AvaSpec ULS-RS-TEC). The EL intensity was obtained by the integration of the measured spectrum for a given phase delay. The transient electroluminescence response of the PeLETs was collected by using a Si photodiode (Newport 818-UV) connected to a low-noise current preamplifier (Stanford Research Systems SR570) and a digital oscilloscope (LeCroy WaveSurfer 104MXs-B). A trigger for the oscilloscope was taken from the waveform generator. The time constant of the amplifier was ≈0.35 μs. All measurements were performed at a low temperature (77 K) to minimize the effects of ionic drift and maximize electroluminescence intensity. Source and drain electrodes in Figures 1b,d and 2 were false-colored using GIMP software. Neither the EL emission nor the background was digitally colored or processed/modified.

**Impedance Spectroscopy:** Impedance spectroscopy measurements were conducted using a vertical multilayer device consisting of Si/SiO<sub>2</sub> (500 nm)/MAPbI<sub>3</sub> (400 nm)/Au (100 nm). The perovskite layer and the Au top electrode were deposited in the same manner as for PeFET transistors. Impedance measurements were performed using a potentiostat (BioLogic SP-200) over a frequency range of 100 Hz to 1 MHz, with an applied AC voltage of 30 mV. The measurements were conducted in the dark to avoid photocapacitive effects.<sup>[37]</sup>

**Simulations:** Numerical simulations were performed in LTspice XVII (Analog Devices, Inc.) software based on the standard mathematical Grove–Frohman MOSFET model (MOSFET Model LEVEL 2).<sup>[26]</sup> The modified trap integration method was applied, while the maximum timestep was three orders of magnitude lower than the voltage modulation period. Parameters, such as field-effect mobility, C<sub>gs</sub>, and C<sub>gd</sub> capacitances, as well as device dimensions used in the simulations, were defined based on the experiments. As the PeLET operates in the *n*-type regime, only electron current was considered.

### Supporting Information

Supporting Information is available from the Wiley Online Library or from the author.

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### Conflict of Interest

The authors declare no conflict of interest.

## Author Contributions

M.K. and C.S. conceived the idea. M.K. fabricated the light-emitting devices and carried out all electrical and optical measurements with support of B.W.H.C. A.B. was responsible for perovskite films preparation. M.K. and K.B. developed the equivalent circuit model and performed numerical simulations. M.K. and C.S. performed data analysis and wrote the manuscript with inputs from all authors. C.S. supervised the work.

## Data Availability Statement

The data that support the findings of this study are openly available in DR-NTU (Data) at <https://doi.org/10.21979/N9/FPXQPA>, reference number 1.

## Keywords

capacitive effects, electroluminescence modulations, light-emitting transistors, metal-halide perovskites, numerical circuit modeling, pulsed light-emitting devices

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